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PATENT

Attorney Docket No.: AM524R1/T289

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Assistant Commissioner for Patents
Washington, D.C. 20231

On 3/2/99

TOWNSEND and TOWNSEND and CREW LLP

By: Sandy ZK



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

MUSAKA et al.

Application No.: 09/187,551

Filed: November 5, 1998

For: METHOD OF FORMING A THIN FILM FOR A SEMICONDUCTOR DEVICE

Examiner: Unassigned

Art Unit: 1762

INFORMATION DISCLOSURE
STATEMENT UNDER 37 CFR §1.97 and
§1.98

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Assistant Commissioner for Patents

Washington, D.C. 20231

Sir:

The references cited on attached form PTO-1449 are being called to the attention of the Examiner. Copies of the references are enclosed. It is respectfully requested that the cited information be expressly considered during the prosecution of this application, and the references be made of record therein and appear among the "references cited" on any patent to issue therefrom.

Applicant believes that no fee is required for submission of this statement, since it is being submitted prior to the first Office Action. However, if a fee is required, the Commissioner is authorized to deduct such fee from the undersigned's Deposit Account No.

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20-1430. Please deduct any additional fees from, or credit any overpayment to, the above-noted Deposit Account.

Respectfully submitted,



Scott W. Hewett
Reg. No. 41,836

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